Search Notes			

Application/Control No.	Applicant(s)/Patent under Reexamination
10/510,591	KLOEN ET AL.
Examiner	Art Unit
Chris C. Chu	2815

	SEARCHED		
Class	Subclass	Date	Examiner
257	678, 787, 781 and 786	6/30/2005	C.C.
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
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SEARCH NOT (INCLUDING SEARCH)
·	DATE	EXMR
Searched in US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; and IBM_TDB;	6/30/2005	C.C.
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